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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10014131	12/13/2001	445	?	2879	Ramsey

**APPLICANTS: Onishi Toshikazu; Banwa Yoshikezui; Nishimura Michiyo; Takeda Toshihiko; Yamamoto Keisuke; Maruyama Tomoko;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV C/F 09/848,360 05/04/2001
WHICH IS A DIV OF 09/248,102 02/11/1999 PAT 6,267,636

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 10-029538 02/12/1998

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO	
35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no	35.C13314 D2	
Verified and Acknowledged Examiner's initials			
TITLE : Method for manufacturing electron emission element, electron source, and image forming apparatus			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
		Assistant Examiner	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.
		Print Fig.	
TERMINAL		Primary Examiner	
DISCLAIMER		Application Examiner	
PREPARED FOR ISSUE			
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